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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. KAWAGUCHI, et al  
Serial No.: 10/083,252  
Filed: February 27, 2002  
For: PLASMA PROCESSING METHOD AND APPARATUS  
Group: 1765  
Examiner: S. Ahmed

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 9, 2004

Sir:

In response to the Office Action dated January 9, 2004, the following  
amendments and remarks are respectfully submitted in connection with the above-  
identified application, as listed below and as set forth on the following pages:

Amendment of the Specification and Abstract;

Amendment of the Claims;

Remarks are included following the amendments;

Amendments to the Drawings describing changes to the drawings shown in  
the Appendix; and

An Appendix including amended drawing figures is attached following the  
Remarks.